

**IN THE UNITED STATES DESIGNATED/ELECTED OFFICE**

International Application No. : PCT/JP05/02705  
International Filing Date : February 21, 2005  
Priority Date(s) Claimed : March 31, 2004  
Applicant(s) (DO/EO/US) : Kazuyoshi INOUE et al

Title: INDIUM OXIDE-CERIUM OXIDE BASED SPUTTERING TARGET,  
TRANSPARENT ELECTROCONDUCTIVE FILM, AND PROCESS FOR  
PRODUCING A TRANSPARENT ELECTROCONDUCTIVE FILM  
**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

Prior to calculating the national fee, and prior to examination in the National Phase of the above-identified International application, please amend as follows:

Amendments to the Specification begin on page of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the begin on page of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 4 of this paper.